

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Patent Application

Inventor (s)	Baer et al.	Docket No.	HSJ9-2003-0032US1
Serial No.	Not yet assigned	Art Unit	Not yet assigned
Filing Date	Not yet assigned	Examiner	Not yet assigned
Title:	METHOD OF FORMING A READ SENSOR USING PHOTORESIST STRUCTURES WITHOUT UNDERCUTS WHICH ARE REMOVED USING CHEMICAL-MECHANICAL POLISHING (CMP) LIFT- OFF PROCESSES		

MAIL STOP PATENT APPLICATION

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

SIR:

INFORMATION DISCLOSURE STATEMENT

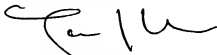
In accordance with 37 CFR 1.97(b), the enclosed Information Disclosure Statement, with attached reference(s), is submitted for consideration in the above-identified application.

A copy of each of the listed documents is enclosed.

NO FEE IS REQUIRED.

The Examiner is respectfully requested to make the listed documents of record in connection with the prosecution of the subject application.

Respectfully,



John J. Oskorep  
Reg. # 41,234

Date: 30 Sept 2003

John J. Oskorep  
One Magnificent Mile Center  
980 N. Michigan Avenue, Suite 1400  
Chicago, Illinois 60611  
Voice: 312-222-1860 Fax: 312-214-6303  
Email: joskorep@securepatents.com

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<b>Substitute for form 1449A/PD</b>  <b>INFORMATION DISCLOSURE STATEMENT BY APPLICANT</b> <i>(use as many sheets necessary)</i>		<b>COMPLETE IF KNOWN</b>	
		Application Number	Not Yet Assigned
		Filing Date	Not Yet Assigned
		First Named Inventor	Baer
		Group Art Unit	Not Yet Assigned
		Examiner Name	Not Yet Assigned
SHEET	1	OF	1
		Docket Number	HS-9-2003-0032US1

U.S. PATENT DOCUMENTS						
Examiner Initials*	Cite No. <sup>1</sup>	U.S. Patent Document		Name of Patentee or Applicant of Cited Document	Date of Publication of Cited Document MM-DD-YYYY	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear
		Number	Kind Code <sup>2</sup> (If known)			
		6,353,995	B1	Sasaki et al.	03-12-2002	
		5,087,332		Chen	02-11-2002	
		6,483,664		Kamijima	11-19-2002	
		6,195,229	B1	Shen et al.	02-27-2001	

FOREIGN PATENT DOCUMENTS							
Examiner Initials*	Cite No. <sup>1</sup>	Foreign Patent Document		Name of Patentee or Applicant of Cited Document	Date of Publication of Cited Document MM-DD-YYYY	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear	T <sup>6</sup>
		Office <sup>3</sup>	Number <sup>4</sup>				

OTHER PRIOR ART - NON PATENT LITERATURE DOCUMENTS			
Examiner Initials*	Cite No. <sup>1</sup>	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published	T <sup>6</sup>

Examiner Signature	Date Considered
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\*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

<sup>1</sup>Unique citation designation number. <sup>2</sup>See attached Kinds of U.S. Patent Documents. <sup>3</sup>Enter Office that issued the document, by the two letter-code (WIPO Standard ST.3).

<sup>4</sup>For Japanese patent documents, the indication of the year of the reign of the Emperor must precede the serial number of the patent document. <sup>5</sup>Kind of document by the appropriate symbols as indicated on the document under WIPO Standard St. 16 if possible. <sup>6</sup>Applicant is to place a check mark here if English language translation is attached.